

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.	:	10/595,660	Confirmation No. 4264
Applicant	:	Yuichiro Shindo	
371 Filed	:	May 3, 2006	
Art Unit	:	1793	
Examiner	:	Jessee Randall Roe	
Customer No.	:	00270	
Title	:	HIGH PURITY HAFNIUM, TARGET AND THIN FILM COMPRISING SAID HIGH PURITY HAFNIUM, AND METHOD FOR PRODUCING HIGH PURITY HAFNIUM	

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE**

Sir:

This is a Response submitted with a Request for Continued Examination (RCE) in timely response to a FINAL Office Action dated August 19, 2010.

**Remarks/Arguments** begin on page 2 of this paper.